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Docket No.: M4065.0243/P243 A
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Craig A. Hickman et al.

Application No.: 10/771,291

Confirmation No.: 3240

Filed: February 5, 2004

Art Unit: 2857

For: WAFER ALIGNMENT SYSTEM

Examiner: Hal D. Wachsman

SUPPLEMENTAL AMENDMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated November 8, 2004, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.